

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Uwe SCHWARZ

Serial No: 10/537,211

Examiner: Reema Patel

Filed: March 20, 2006

Group Art Unit: 2812

For: PRODUCTION OF MICROELECTROMECHANICAL SYSTEMS (MEMS) USING  
THE HIGH TEMPERATURE SILICON FUSION BONDING OF WAFERS

Confirmation: 1865

PETITION FOR EXTENSION OF TIME, 37 C.F.R. §1.136(a)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant request retroactive extension of the term for response to the official action mailed May 15, 2007, to and including the filing of the accompanying amendment under 37 C.F.R. §1.111. The required official fee for a two month extension is submitted by EFS charge authorization. Please charge any underpayment or credit any overpayment to Deposit Account 04-1679.

Respectfully submitted,

Date: October 12, 2007

/Stephan Gribok/

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Attorney Docket: D4695-00135  
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